

PATENT  
Docket No. 20067/OPP031479US

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant(s): Tae-Hee Park

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Serial No.: 10/749,650

April 30, 2004

Filed: December 30, 2003



Mark C. Zimmerman  
Registration No. 44,006  
Attorney for Applicant(s)

For: "Methods of Forming Metal Lines in  
Semiconductor Devices"

Group Art Unit: Unknown

Examiner: Unknown

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The patents listed on the enclosed PTO Form-1449 are submitted pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the patents are enclosed.

TIME OF FILING

This information disclosure statement is being filed, to the best of the undersigned's knowledge, before the mailing date of a first Office action on the merits. In accordance with 37 CFR §1.97(b), no certification or fee is required.

**METHOD OF PAYMENT**

No fee is required.

The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 50-2455. A copy of this paper is enclosed.

Correspondence Address:

Respectfully submitted,

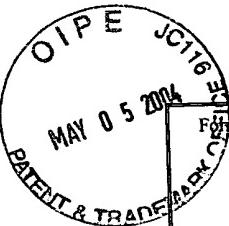
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**April 30, 2004**



Form PTO-1449 (Modified)

U.S. Department of Commerce  
Patent and Trademark OfficeAtty. Docket No.  
20067/OPP031479USSerial No.  
10/749,650
**INFORMATION DISCLOSURE STATEMENT**  
*(Use several sheets if necessary)*

Applicant

Tae-Hee Park

Filing Date

December 30, 2004

Group Art Unit  
Unknown**U.S. PATENT DOCUMENTS**

*EXAMINER INITIALS		DOCUMENT NUMBER	ISSUE DATE	INVENTOR(S)	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A01	5,886,410	05-23-1999	Chien Chang, et al.	257	759	
	A02	6,238,582	05-29-2001	Kurt Williams, et al.	216	22	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.